

Docket: 740756-2422

3-19-02
31000 U.S. PTO
10/053572
01/24/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Hideto OHNUMA)
Japanese Priority Application No. 2001-019293) Attn: Applications
Japanese Priority Date: January 26, 2001:) Branch
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE) Date: January 24, 2002

INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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